



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 1, 2026	
IGI Report Number	LG804647391
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	7.89 X 5.80 X 3.65 MM

GRADING RESULTS

Carat Weight	1.04 CARAT
Color Grade	E
Clarity Grade	VS 2

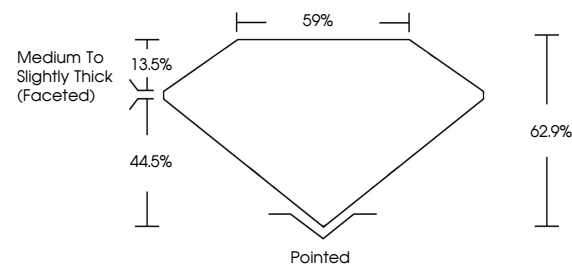
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG804647391

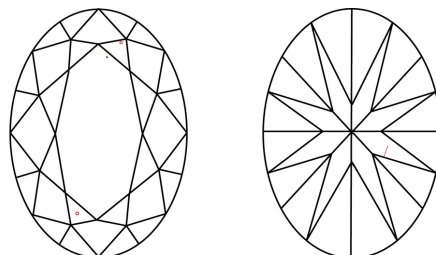
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG804647391
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

June 1, 2026
GI Report No LG804647391

1.04 CARAT	VS 2	62.9%	59%	Medium to Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE
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